## What is claimed is:

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- 1. Polarization interferometric apparatus, said
- 2 apparatus comprising interferometer means for receiving at
- 3 least two beams having orthogonal states of polarization
- 4 and providing first and second interferometer legs,
- 5 separating said two beams for travel along said first and
- 6 second interferometer legs, respectively, and generating
- 7 exit beams containing information about the respective
- 8 differences in the optical paths each beam experienced in
- 9 traveling said first and second interferometer legs, said
- 10 first and second interferometer legs having optical paths
- 11 structured and arranged such that at least one of them has
- 12 a variable physical length, the optical path length
- difference between said first and second interferometer
- 14 legs varying in accordance with the difterence between the
- 15 respective physical lengths of their optical paths and
- 16 wherein at least one of said first and second
- interferometer legs comprises a polarization preserving
- 18 optical system.
- 1 2. The polarization interferometric apparatus of
- 2 claim 1 further including means for combining said exit
- 3 beams to produce mixed optical signals containing
- 4 information corresponding to the phase differences between
- 5 each of said exit beams from corresponding ones of said
- 6 predetermined optical paths of said first and second
- 7 interferometer legs.
- 1 3. The polarization interferometric apparatus of
- 2 claim 2 further including means for detecting said mixed



- 3 optical signals and generating electrical interference
- 4 signals containing information corresponding to the
- 5 difference in physical path lengths of said interferometer
- 6 legs and their relative rate of change.
- 4. The polarization interferometric apparatus of
- 2 claim 3 further including electronic means for analyzing
- 3 said electrical interference signals.
- 1 5. The polarization interferometric apparatus of
- 2 claim 1 wherein said polarization preserving optical
- 3 system comprises a plurality of reflecting surfaces
- 4 arranged such that a change in the direction of
- 5 propagation of an input beam, normal to both the input
- 6 beam and an output beam, causes a change in the direction
- 7 of propagation of the output beam in a direction opposite
- 8 to the direction of the change in the input beam, and a
- 9 change in the direction of propagation of the input beam,
- 10 normal to the input beam and in a plane orthogonal to a
- 11 normal to both the input beam and the output beam, causes
- 12 a rotation in the output beam in said plane that is the
- 13 same as a corresponding rotation of the input beam caused
- 14 by the change in the direction of propagation of the input
- 15 beam and wherein the plane of incidence at each of said
- 16 reflecting surfaces is either orthogonal or parallel to
- 17 the plane of polarization of an incident beam thereto.
- 1 6. The polarization interferometric apparatus of
- 2 claim 1 wherein said interferometer means comprises at
- 3 least one polarizing beam splitter for separating
- 4 orthogonally polarized beams for travel along



- corresponding ones of said first and second interferometer 5
- 6 legs.
- The polarization interferometric apparatus of 1
- claim 1 wherein said interferometer means comprises at 2
- least one plane mirror in one of said interferometer legs. 3
- The polarization interferometric apparatus of 8. 1
- claim 7 wherein said interferometer means comprises at 2
- least two polarization preserving optical systems, one for 3
- reflecting beams corresponding to one interferometer leg 4
- and another for reflecting beams corresponding to said 5
- other interferometer leg.
- 9. The polarization interferometric apparatus of 1
- claim 8 wherein said interferometer means further 2
- comprises a polarization beam splitter for separating 3
- orthogonally polarized beams and one of each of said at 4
- least two polarization preserving optical systems is 5
- arranged on opposite sides of said polarizing beam 6
- splitter. 7
- 1 10. The polarization interferometric apparatus of
- claim 1 wherein said interferometer means comprises a 2
- plurality of optical elements, which include said 3
- polarization preserving optical system, composed of glass
- and arranged such that said separated beams traveling 5
- along said first and second interferometer legs travel
- through said optical elements composed of glass over 7
- substantially equal optical path lengths to compensate for 8
- thermal effects.



- 11. The polarization interferometric apparatus of 1 claim 10 wherein said plurality of optical elements include a polarizing beam splitter having an entrance 3 facet, an exit facet, a top facet, and a bottom facet, a 4 first fixed plane mirror arranged above and substantially 5 parallel to said top facet, a first quarter-wave plate 6 located intermediate said first plane mirror and said top 7 facet, a second movable plane mirror arranged 8 substantially parallel to and opposite to said exit facet, 9 a second quarter-wave plate fixedly located intermediate 10 said second plane mirror and said exit facet, and wherein 11 said polarization preserving optical system is arranged 12 opposite to said bottom facet. 13
- The polarization interferometric apparatus of 1 claim 10 wherein said plurality of optical elements 2 include a polarizing beam splitter having an entrance 3 facet, an exit facet, a top facet, and a bottom facet, a first quarter-wave plate located immediately adjacent said 5 exit facet, a first fixed plane mirror arranged opposite 6 to and substantially parallel to said quarter-wave plate, 7 a second movable plane mirror arranged substantially 8 parallel to and adjacent said first fixed plane mirror, a 9 pair of half-wave plates located opposite and 10 substantially parallel to said entrance facet, and wherein 11 said polarization preserving optical system is arranged 12 opposite to said bottom facet, said first and second plane 13 mirrors being moveable relative to one another such that 14 opposing surfaces thereof may contact one another to form 15 a substantially zero air gap between them. 16







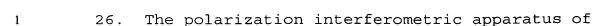
- 13. The polarization interferometric apparatus of 1 claim 10 wherein said plurality of optical elements include a polarizing beam splitter having an entrance 3 facet, an exit facet, a top facet, and a bottom facet, a 4 first fixed plane mirror arranged above and substantially 5 perpendicular to said top facet, a first quarter-wave 6 plate located intermediate said first plane mirror and 7 said top facet, a 45 degree mirror arranged between said 8 first quarter-wave plate and said first plane mirror, a 9 second movable plane mirror arranged substantially 10 parallel to and opposite to said exit facet, a second 11 quarter-wave plate fixedly located intermediate said 12 second plane mirror and said exit facet, and wherein said 13 polarization preserving optical system is arranged 14 opposite to said bottom facet, said first and second plane 15 mirrors being substantially parallel to one another. 16
- 14. The polarization interferometric apparatus of 1 claim 1 wherein said interferometer means is further 2 configured for receiving a second set of two beams and 3 providing a second set of first and second interferometer 4 legs, offset with respect to one another, separating said 5 two beams for travel along said second set of said first 6 and second interferometer legs, respectively, and 7 generating exit beams containing information about the 8 respective differences in the optical paths each beam 9 experienced in traveling said second set of said first and 10 second interferometer legs, said second set of said first 11 and second interferometer legs having optical paths 12 structured and arranged such that at least one of them has 13 a variable physical length, the optical path length 14

- 15 difference between said second set of said first and
- 16 second interferometer legs varying in accordance with the
- 17 difference between the respective physical lengths of
- 18 their optical paths and wherein at least one of said
- 19 second set of first and second interferometer legs
- 20 comprises a second polarization preserving optical system
- 21 to reduce polarization mixing between said second set of
- 22 two beams, whereby said polarization interferometric
- 23 apparatus is capable of measuring linear and angular
- 24 displacements.
- 1 15. The polarization interferometric apparatus of
- 2 claim 1 further including means for generating at least
- 3 two beams having orthogonal states of polarization.
- 1 16. The polarization interferometric apparatus of
- 2 claim 15 wherein said two beams have different
- 3 wavelengths.
- 1 17. The polarization interferometric apparatus of
- 2 claim 16 wherein said different wavelengths are
- 3 harmonically related.
- 1 18. The polarization interferometric apparatus of
- 2 claim 1 wherein said orthogonally polarized beams are
- 3 spatially separated.
- 1 19. The polarization interferometric apparatus of
- 2 claim 1 wherein said orthogonally polarized beams travel
- 3 along a coextensive path.



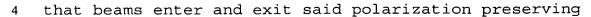
- 20. The polarization interferometric apparatus of
  claim 5 wherein said polarization preserving
  cofficial system
  retroreflector is fabricated of a plurality of prismatic
  optical elements wherein said plurality of reflecting
  surfaces comprise selected surfaces of said plurality of
  prismatic optical elements.
- 1 21. The polarization interferometric apparatus of 2 claim 20 wherein at least one of said surfaces of said 3 plurality of prismatic optical elements operates by total 4 internal reflection.
- The polarization interferometric apparatus of 1 claim 20 wherein said plurality of prismatic optical 2 3 elements comprise an integral assembly in which at least one surface of each prismatic optical element contacts at 4 least one surface of another of said prismatic optical 5 elements. 23. The polarization interferometric apparatus 6 of claim 20 further including at least one polarizing beam 7 8 splitter.
- 1 24. The polarization interferometric apparatus of 2 claim 22 wherein said integral assembly further comprises 3 at least one polarizing beam splitter.
- 1 25. The polarization interferometric apparatus of 2 claim 20 wherein said prismatic elements of said optical 3 system comprise at least one prismatic element selected 4 from the group consisting of Porro, right, Dove, penta, 5 and "K" prisms.





- 2 claim 20 wherein said prismatic elements include a right,
- 3 a Porro and a penta prism.
- 1 27. The polarization interferometric apparatus of
- 2 claim 5 wherein at least one of said plurality of said
- 3 reflecting surfaces comprises a mirror.
- 1 28. The polarization interferometric apparatus of
- 2 claim 5 wherein at least one of said plurality of
- 3 reflecting surfaces has formed thereon a multilayer
- 4 polarizing beam splitter coating arrangement to enhance
- 5 the extinction ratio between orthogonally polarized beams
- 6 entering said polarization preserving retroreflector from
- 7 upstream of it.
- 1 29. The polarization interferometric apparatus of
- 2 claim 20 wherein at least one of said plurality of
- 3 prismatic optical elements is formed of a birefringent
- 4 optical material.
- 1 30. The polarization interferometric apparatus of
- 2 claim 5 wherein said plurality of reflecting surfaces are
- 3 configured and arranged with respect to one another such
- 4 that beams enter and exit said polarization preserving
- 5 optical system substantially parallel and offset with
- 6 respect to one another.
- 1 31. The polarization interferometric apparatus of
- 2 claim 5 wherein said plurality of reflecting surfaces are
- configured and arranged with respect to one another such





- 5 optical system substantially at right angles to one
- 6 another.
- 1 32. The polarization interferometric apparatus of
- 2 claim 31 wherein said plurality of reflecting surfaces are
- 3 further configured and arranged with respect to one
- 4 another such that beams that enter and exit said
- 5 polarization preserving optical system substantially at
- 6 right angles to one another also reside in planes that are
- offset with respect to one another.
- 1 33. The polarization interferometric apparatus of
- 2 claim 30 wherein said plurality of reflecting surfaces are
- 3 further configured and arranged with respect to one
- 4 another such that an array of entering beams to said
- 5 polarization preserving optical system exit it as an array
- 6 of exiting beams substantially parallel to said array of
- 7 entering beams, said array of entering beams being offset
- 8 with respect to said array of exiting beams with both
- 9 residing in the same plane.
- 1 34. The polarization interferometric apparatus of
- 2 claim 30 wherein said plurality of reflecting surfaces are
- 3 further configured and arranged with respect to one
- 4 another such that an array of entering beams to said
- 5 polarization preserving optical system exit it as an array
- 6 of exiting beams substantially parallel to said array of
- 7 entering beams, said array of entering beams residing in
- 8 planes that are offset with respect to one another.



- 1 35. The polarization interferometric apparatus of
- claim 5 wherein said plurality of reflecting surfaces are
- 3 configured and arranged with respect to one another such
- 4 that beams enter and exit said polarization preserving
- 5 optical system at preselected angles other than 180
- 6 degrees.
- 1 36. The polarization interferometric apparatus of
- 2 claim 20 wherein said plurality of prismatic optical
- 3 elements comprises, in sequence from entering to exiting
- 4 light beams, a Porro prism and a right angle prism.
- 1 37. The polarization interferometric apparatus of
- 2 claim 20 wherein said plurality of prismatic optical
- 3 elements comprises, in sequence from entering to exiting
- 4 light beams, a Porro prism and a Dove prism.
- 1 38. The polarization interferometric apparatus of
- 2 claim 20 wherein said plurality of prismatic optical
- 3 elements comprises, in sequence from entering to exiting
- 4 light beams, a right angle prism, Porro prism and a penta
- 5 prism.
- 1 39. The polarization interferometric apparatus of
- 2 claim 38 wherein one facet of said right angle prism
- 3 serves as an entrance facet and one facet of said penta
- 4 prism serves as an exit facet, said entrance and said exit
- facets being parallel to one another.
- 1 40. The polarization interferometric apparatus of
- 2 claim 39 further including at least one polarizing beam



- 3 splitter arranged upstream of said entrance facet of said
- 4 right angle prism.
- 1 41. The polarization interferometric apparatus of
- 2 claim 40 wherein one surface of said polarizing beam
- 3 splitter and said entrance surface of said right angle
- 4 prism are in optical contact with one another.
- 1 42. The polarization interferometric apparatus of
- 2 claim 1 further including in at least one of said
- 3 interferometer legs retardation elements for controlling
- 4 the state of polarization of orthogonally polarized beams
- 5 and reducing the effects of ghost reflections on exit
- 6 beams.
- 1 43. The polarization interferometric apparatus of
- 2 claim 42 wherein said retardation elements comprise a pair
- 3 of quarter wave plates oppositely tilted with respect to
- 4 one another.
- 1 44. The polarization interferometric apparatus of
- 2 claim 1 wherein said interferometer means is further
- 3 structured and arranged such that the orthogonally
- 4 polarized beams make at least a double pass in traveling
- 5 along said interferometer legs.
- 1 45. The polarization interferometric apparatus of
- 2 claim 1 further including a microlithographic means
- 3 operatively associated with said interferometric apparatus
- 4 for fabricating integrated circuits on wafers, said
- 5 microlithographic means comprising:



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at least one stage;

an illumination system for imaging spatially

patterned radiation onto the wafer; and

at least one positioning system for adjusting the

position of said at least one stage;

wherein said interferometric apparatus is adapted to

measure the position of said at least one stage.

- The polarization interferometric apparatus of 1 claim 1 further including a microlithographic means 2 operatively associated with said interferometric apparatus 3 for use in fabricating integrated circuits on a wafer, said microlithographic means comprising: 5 at least one stage for supporting a wafer; 6 an illumination system including a radiation source, 7 a mask, a positioning system, a lens assembly, and 8 predetermined portions of said interferometric apparatus, 9 10 said microlithographic means being operative such that the source directs radiation through said mask to 11 produce spatially patterned radiation, said positioning 12 system adjusts the position of said mask relative to 13 radiation from said source, said lens assembly images said 14 spatially patterned radiation onto the wafer, and said 15 interferometric apparatus measures the position of said 16
- 47. The polarization interferometric apparatus of claim 1 further including microlithographic apparatus operatively associated with said interferometric apparatus for fabricating integrated circuits comprising first and second components, said first and second components being

mask relative to said radiation from said source.



- moveable relative to one another, said first and second
- components being connected with said first and second 7
- measurement legs, moving in concert therewith, such that 8
- said interferometric apparatus measures the position of 9
- said first component relative to said second component. 10
- The polarization interferometric apparatus of 1 48.
- claim 1 further including a beam writing system 2
- operatively associated with said interferometric apparatus 3
- for use in fabricating a lithography mask, said beam 4
- writing system comprising: 5
- a source for providing a write beam to pattern a 6
- substrate: 7
- at least one stage for supporting a substrate; 8
- a beam directing assembly for delivering said write 9
- beam to the substrate; and 10
- a positioning system for positioning said at least 11
- one stage and said beam directing assembly relative to one 12
- 13 another,

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- said interferometric apparatus being adapted to 14
- measure the position of said at least one stage relative 15
- to said beam directing assembly. 16
  - Polarization interferometric apparatus, said apparatus comprising interfetometer means for receiving at
  - least two beams having orthogonal states of polarization
- and providing first and second interferometer legs, 4
- separating said two beams for thavel along said first and 5
- second interferometer legs, respectively, and generating 6
- exit beams containing information\about the respective 7
- differences in the optical paths each beam experienced in 8

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traveling said first and second interferometer legs, said first and second interferometer legs having optical paths structured and arranged such that at least one of them has a variable physical length, the optical path length difference between said first and second interferometer legs varying in accordance with the difference between the respective physical lengths of their optical paths, said interferometer means further including a plurality of opposing surfaces at least some of which are tilted with respect to others to reduce the effects of ghost beams on exit beams.

50. The polarization interferometric apparatus of claim 49 wherein at least one of said first and second interferometer legs includes a polarization preserving optical system.

- 1 51. The polarization interferometric apparatus of 2 claim 1 wherein said interferometer means further includes 3 dynamic means for maintaining the alignment of at least 4 one of said beams as it travels along a corresponding one 5 of said interferometer legs.
- 52. The polarization interferometric apparatus of claim 51 wherein interferometer means comprises at least one plane mirror for receiving one of said beams and said dynamic means comprises a servo controlled mirror for maintaining said beam substantially orthogonal to said plane mirror.

- The polarization interferometric apparatus of 1 claim 1 wherein said interferometer means is further 2 3 configured and arranged for receiving at least two additional beams having orthogonal states of polarization 4 and providing two additional first and second 5 interferometer legs, separating said two additional beams 6 for travel along said two additional first and second 7 interferometer legs, respectively, and generating 8 additional exit beams containing information about the 9 10 respective differences in the optical paths each said additional beam experienced in traveling said additional 11 first and second interferometer legs, said additional 12 first and second interferometer legs having optical paths 13 structured and arranged such that at least one of them has 14 15 a variable physical length, the optical path length difference between said additional first and second 16 interferometer legs varying in accordance with the 17 difference between the respective physical lengths of 18 their optical paths and wherein at least one of said 19 additional first and second interferometer legs comprises 20 21 a polarization preserving optical system.
- 1 54. The polarization interferometric apparatus of 2 claim 53 wherein said interferometer means is configured 3 to simultaneously determine displacement and/or angle 4 along at least two axes.